

<b>MONDAY 23<sup>rd</sup></b> January		
8:45-9:00	Welcome by Prof. Mato Knez	
Session I		
9:00-10:00	Plenary Session	<b>Maarit Karppinen</b> Department of Chemistry, Aalto University, Finland ALD/MLD of novel inorganic-organic hybrid materials and superlattices: from fundamentals to energy applications
10:00-10:30	Oral	<b>Kevin Van de Kerckhove</b> Department of Solid State Sciences, Ghent University, Belgium Molecular Layer Deposition for Applications in Lithium-ion Batteries
10:30-11:00	Oral	<b>Kristian Blindheim Lausund</b> Department of Chemistry University of Oslo, Norway Crystallization of hybrid films to form the metal-organic framework UiO-66
Coffee Break		
Session II		
11:30-12:15	Invited	<b>Ola Nilsen</b> Department of Chemistry, University of Oslo, Norway From ALD to MLD
12:15-12:45	Oral	<b>Jenna Penttinen</b> Department of Chemistry, Aalto-University, Finland Atomic/Molecular Layer Deposition of s-block Carboxylate
12:45-13:15	Oral	<b>Rob Ameloot</b> Center for Surface Chemistry and Catalysis, University of Leuven, Belgium Porous crystals from the vapor phase: chemical vapor deposition of metal-organic frameworks (MOF-CVD)
Lunch Break		
Session III		
14:30-15:15	Invited	TBC
15:15-15:45	Oral	<b>Fieke van den Bruele</b> Holst Centre/TNO, High Tech Campus Eindhoven, The Netherlands Challenges in scaling Molecular Layer Deposition processes
15:45-16:15	Oral	<b>Mercedes Vila Juárez.</b> Coating Technologies S.L.-CTECHnano. San Sebastian, Spain New Trends of Industrial Coatings: Atomic Layer Deposition
16:15-17:30	Expert Discussion	

**TUESDAY 24<sup>th</sup>**  
January

Session VI		
9:15-10:00	Invited	<b>Hayrensa Ablat</b> Tyndall National Institute, University College Cork, Ireland Acrylate-based hybrid thin films grown by Molecular Layer Deposition
10:00-10:30	Oral	<b>Laura Svärd</b> VTT Technical Research Centre of Finland, Espoo, Finland Low-temperature Molecular Layer Deposition using monofunctional aromatic precursors and ozone-based ring opening reactions
10:30-11:00	Oral	<b>Noureddine Adjeroud</b> Luxembourg Institute of Science and Technology, Luxembourg Atomic Layer Deposition of Metalcone
Coffee Break		
Session V		
11:30-12:15	Invited	<b>David Muñoz-Rojas</b> Laboratoire des Matériaux et du Génie Physique (LMGP), Grenoble, France Atmospheric Pressure Spatial Atomic Layer Deposition (AP-SALD): open air deposition of functional thin films at high rates
12:15-12:45	Oral	<b>Itxasne Azpitarte</b> CIC Nanogune Consolider, San Sebastián, Spain Improving the thermal and mechanical properties of Kevlar through MPI
12:45-13:15	Oral	<b>Weike Wang</b> CIC Nanogune Consolider, San Sebastián, Spain Doping of Polyaniline by means of vapor phase infiltration
Lunch Break		
Session VI		
14:30-15:15	Invited	<b>TBC</b>
15:15-15:45	Oral	<b>Leva Momtazi</b> Department of Chemistry, University of Oslo, Norway Future use of ALD scaffolds for tissue engineering
15:45-16:15	Oral	<b>Pirjo Heikkilä</b> VTT Technical Research Centre of Finland Ltd. Finland Core-shell carbon-ceramic hybrid fibres by electrospinning and atomic layer deposition (ALD)
16:15-17:30	Labs Visit	

**WEDNESDAY**  
25<sup>th</sup> January

**IBERIAN ALD**

**Session VII**

9:15-10:00	Invited	<b>Lifeng Liu</b> International Iberian Nanotechnology Laboratory (INL), Braga, Portugal Atomic layer deposition of molybdenum sulfide for use as an electrocatalyst in electrochemical and photoelectrochemical water splitting
10:00-10:30	Oral	<b>Álvaro Blanco</b> Instituto de Ciencia de Materiales de Madrid ICMM-CSIC, Madrid, Spain Fabrication of Photonic Structures with Atomic Layer Deposition
10:30-11:00	Oral	<b>Mariona Coll</b> Institut de Ciència de Materials de Barcelona, ICMA-B-CSIC, Barcelona, Spain Epitaxial complex oxide thin films by atomic layer deposition

**Coffee Break**

**Session VIII**

11:30-12:15	Invited	<b>Rui F. Silva</b> CICECO - Aveiro Institute of Materials, Department of Materials and Ceramic Engineering, Aveiro, Portugal Manganese oxide/carbon nanotubes heterostructures for electrochemical capacitors
12:15-12:45	Oral	<b>Maria Carmen Morant-Miñana</b> CEIT and Tecnun (University of Navarra), CIC nanoGUNE Consolider, San Sebastián, Spain Atomic Layer Deposition of AZO IDEs for monitoring stimuli-responsive ionogels
12:45-13:15	Oral	<b>Fan Yang</b> CIC Nanogune Consolider, San Sebastián, Spain ALD-infiltration/MLD fundamental study: Interaction of TMA with different functional groups (-OH, NH <sub>2</sub> and NO <sub>2</sub> )

**CLOSURE**